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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No. 10/695,727
Filing Date 10/28/2003
Inventorship Craig M. Carpenter et al.
Assignee Micron Technology, Inc.
Group Art Unit 1763
Examiner Karla Moore
Customer No. 021567
Attorney's Docket No. MI22-2433
Title: Semiconductor Substrate Processing Chamber and Accessory Attachment
Interfacial Structure


SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References - See Attached Form PTO-1449

The attached Form PTO-1449 is submitted in compliance with 37 CFR §1.56. Pursuant to FEDERAL REGISTER, Vol. 69, No. 182, pg. 56542 (September 21, 2004), no copies of any cited U.S. patents or U.S. published applications are included herewith. No admission is made regarding whether the listed references are prior art.

FW550714897

Respectfully submitted,

Dated: 5-18-07By: 
Mark S. Matkin
Reg. No. 32,268

Form PTO-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. M22-2433	SERIAL NO. 10/695,727
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)		APPLICANT: Craig M. Carpenter et al.	
		FILING DATE October 28, 2003	GROUP 1763

U.S. PATENT DOCUMENTS							
Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate
	AA	5,884,009	3/1989	Okase, Watanu			
	AB	6,111,225	8/2000	Ohkase et al.			
	AC	6,814,813	11/2004	Dando et al.			
	AD	2005/0028734	2/2005	Carpenter et al.			
	AE	2004/0089240	5/2004	Dando et al.			
	AF						
	AG						
	AH						
	AI						

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FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AJ							
	AK							
	AL							

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)			
	AM		
	AN		
EXAMINER		DATE CONSIDERED	

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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The stamp of the U.S. Patent and Trademark Office acknowledges receipt of the following papers relating to the Patent application of Ross S. Dando et al. , Serial No. 10/695,727, filed October 28, 2003, entitled "Semiconductor Substrate Processing Chamber and Accessory Attachment Interfacial Structure".

1. PTO Return Postcard Receipt
2. A \$180.00 check
3. Transmittal Form (PTO/SB/21) & Fee Transmittal (PTO/SB/17) in duplicate
4. Supplemental Information Disclosure Statement with Form PTO-1449

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